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FAX NO.

P. 01

Patent

Customer No.: 31561  
Docket No. 12474-US-PA  
Application No.: 10/711,379

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of  
Applicant : Lu et al.  
Application No. : 10/711,379  
Filed : September 15, 2004  
For : METHOD OF PLANARIZING SPIN-ON MATERIAL  
LAYER AND MANUFACTURING PHOTORESIST LAYER  
Art Unit : 2818  
Examiner : NHU, DAVID

**RESPONSE TO NOTICE REGARDING DRAWINGS**

+1-703-746-4000  
(Via fax: 1+9 pages)

U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop Issue Fees  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Dear Sir,

In reply to the Notice Regarding Drawings mailed on August 26, 2005, transmitted herewith please find Replacement Sheets for corrected drawings in 9 pages.

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

Respectfully Submitted,  
JIANQ CHYUN Intellectual Property Office

Date: Sept. 13, 2005

By: Belinda Lee  
Belinda Lee  
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